

Chemical Vapour Deposition of Titanium Chalcogenides and Pnictides and Tungsten Oxide Thin Films

Robert G. Palgrave and Ivan P. Parkin*

*Author to whom correspondence should be addressed

University College London, Department of Chemistry, 20 Gordon Street, London, UK
WC1H 0AJ.

Electronic Supplementary Information

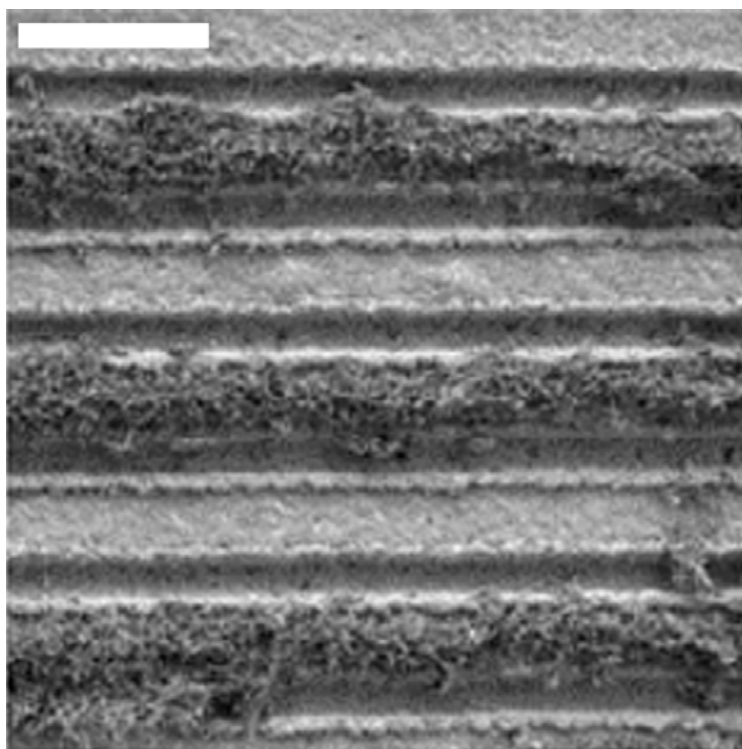


Fig. S1: SEM of a WO₃ film deposited by CVD onto an electrode array with an applied field of 10 V dc; scale bar: 2 microns